To:

Technology Unit: 1753

Facsimile Number: 571-273-8300

Total Pages Sent 8

From:

W. Daniel Swayze, Jr.

Texas Instruments Incorporated

Facsimile: 972-917-4418 Phone: 972-917-5633 RECEIVED
CENTRAL FAX CENTER

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

DEC 2 1 2005

CERTIFICATION OF FACSIMILE TRANSMISSION

I hereby certify that the following papers are being transmitted by

facsimile to the U.S. Patent and Trademark Office at 571-273-8300 on

the date shown below:

Temmie Chambers

Date

FACSIMILE COVER SHEET

X FACSIMILE COVER SHEET NEW APPLICATION DECLARATION (# Pages) ASSIGNMENT (# Pages) FORMAL DRAWINGS INFORMAL DRAWINGS CONTINUATION APP'N (# Pages) DIVISIONAL APP'N		X AMENDMENT 116 (6 Pages) X EOT (1 Month) NOTICE OF APPEAL APPEAL (# Pages) ISSUE FEE (# Pages) CHANGE IN CORRESPONENCE ADDRESS
NAME OF INVENTOR(S): Jaiswal		Serial No.: 10/679,783
TITLE OF INVENTION:		Filing Date: 10/6/2003
CONTROL OF NICHROME RESISTOR TEMPERATURE COEFFICIENT USING RF PLASMA SPUTTER ETCH		
TI FILE NO.:	DEPOSIT ACCT, NO.:]
TI-34403.1	20-0668	
FAXED: /2-2/2/5- DUE: 12/16/2005 ATTY/SECY: WDS/IIc		

This facsimile is intended only for the use of the address named and contains legally privileged and/or confidential information. If you are not the intended recipient of this telecopy, you are hereby notified that any dissemination, distribution, copying or use of this communication is strictly prohibited. Applicable privileges are not waived by virtue of the document having been transmitted by Facsimile. Any misdirected facsimiles should be returned to the sender by mail at the address indicated on this cover sheet.

Texas Instruments Incorporated PO Box 655474, M/S 3999 Dallas, TX 75265